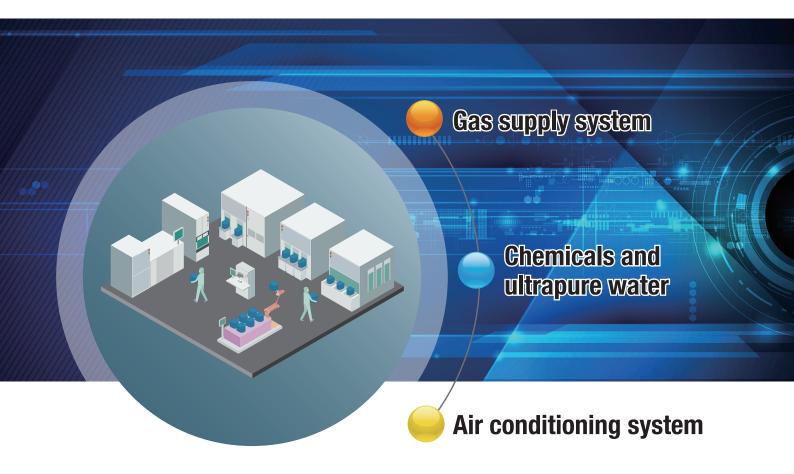
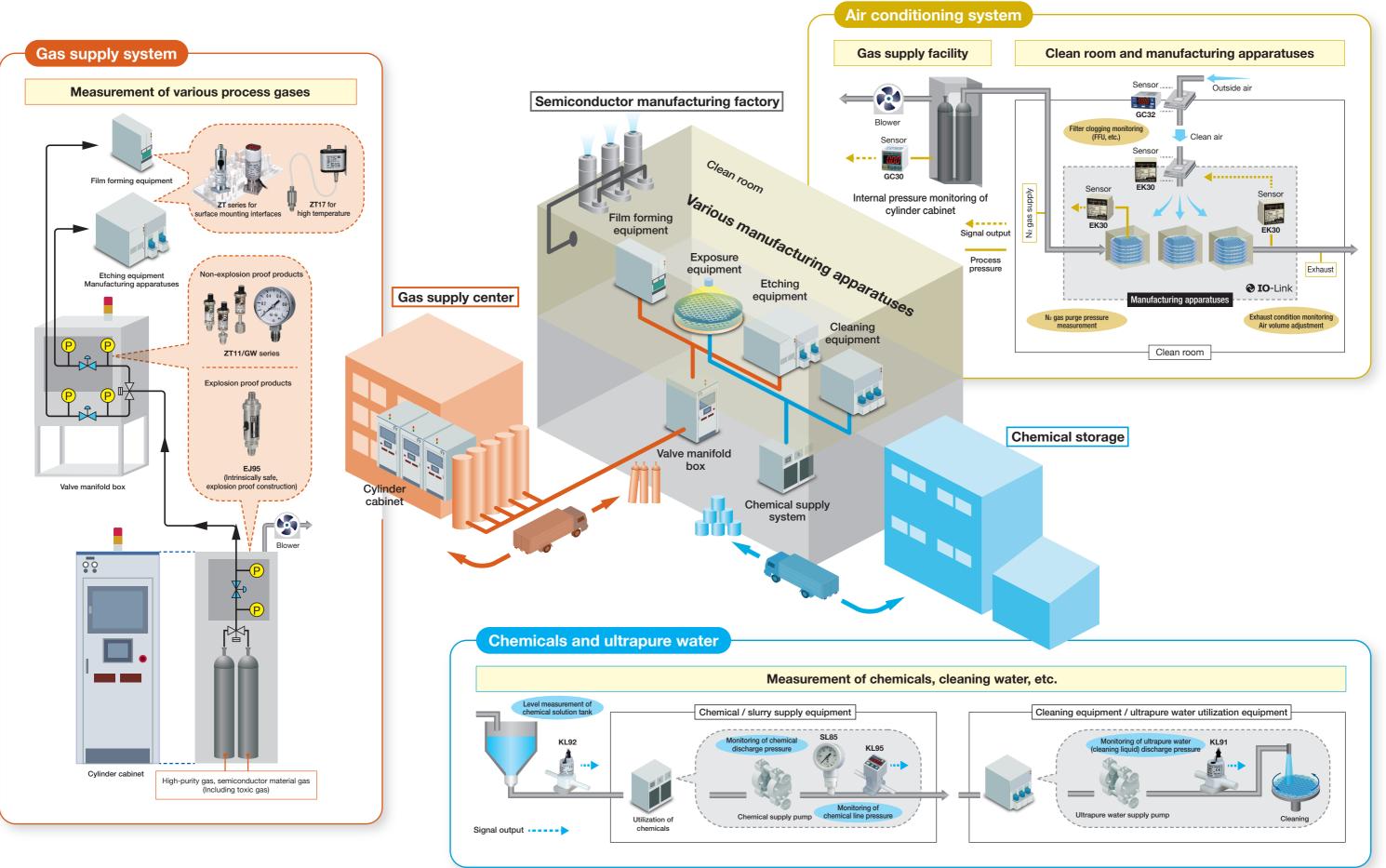


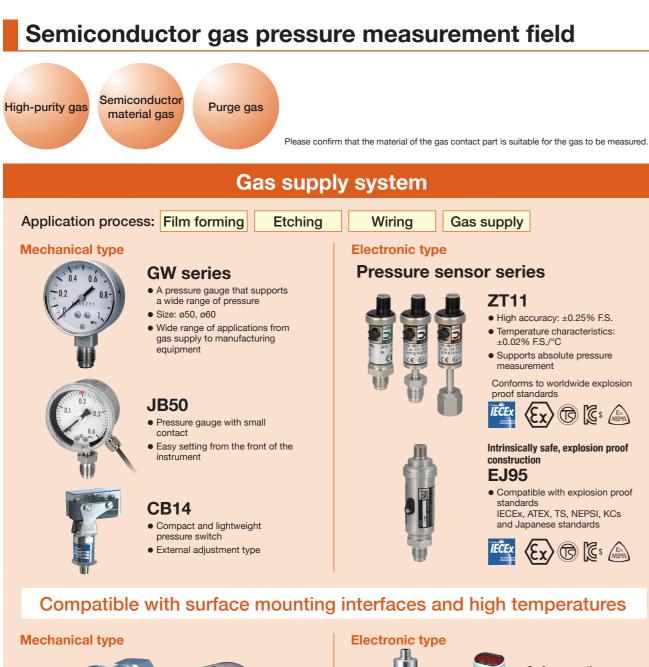
Pressure measurement instruments for the semiconductor industry

The semiconductor industry is the foundation for all of today's most advanced technology. We support this industry by creating new value with advanced pressure measurement technology



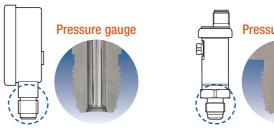


Pressure measurement instruments for the semiconductor industry



Surface mounting interface **ZT** series • 1.125 surface mounting interface Highly visible LED display (ZT61) **GW28 GW35 ZT16 ZT61** Digital Pressure transmitter pressure gauge Surface mounting interface GW series High temperature compatible • Compact gauges for surface mounting interfaces **ZT17** • Size: ø28, ø35, ø40 (200°C compatible) • Pressure sensor capable of measurement at high temperatures • Supports measurement of Ű objects up to 200°C (sensor and cable)

Welding structure suitable for semiconductor gas supply systems due to special surface treatment technology to minimize retention of measured gas.



Grade list and applicable products

These products have been assembled, adjusted, inspected and packaged in a clean room, with special attention to cleanliness.

Pressure gauges

Grade	BA (Bright Annealing)	EP (Electro Polishing)			
Gas contact part material	SUS316L	SUS316L (Gas contact surface polishing)			
Cleanliness	Class VI (ANSI B40. 1M-1979)	10 or less particles of 0.2 μm or larger			
Leakage (helium leak rate)	1.01 x 10 ⁻⁹ Pa·m³/s or less				
Cleaning	(1) Coarse cleaning (2) Ultrasonic cleaning (3) Finish cleaning (4) N_2 gas flushing				
Work area	(1) Clean room (Class 10,000) (2) Clean bench (Class 100)				
Adjustment test media	N ₂ gas				
Packaging form	Sealed polyethylene bag				
Applicable products	GW28, GW35, GW45				

Pressure sensors

Grade		UC (Ultra Clean)	BA (Bright Annealing)	EP (Electro Polishing)	GP (General Purpose)
Roughness of gas contact part		0.18µm Ra Avg. 0.7µm Rz Max.	Approx. Rz 2.5 µm	0.18µm Ra Avg.	0.5µm Ra Avg.
Gas contact	Pressure sensor	Co-Ni alloy		SUS316L	
parts materials	Fitting*1	SUS316L		SUS316L	
Maximum allowable pressure*2		200% of	rated pressure	150% of rated pressure	
Leakage (helium leak rate)		5 x 10 ⁻¹² Pa·m ³ /s or less		5 x 10 ⁻¹² Pa·m ³ /s or less	
Particle		Zero count for size 0.1 µm or greater (as per internal inspection standard)	No regulation	Zero count for size 0.1 µm or greater (In our inspection standard)	No regulation
Cleaning		Ultra clearance (cleaning)	Degreasing	Ultra clearance (cleaning)	Degreasing
Recommended gases*3		High-purity gas, semiconductor material gas, etc.	Purge gas, exhaust gas, etc.	High-purity gas, semiconductor material gas, etc.	Purge gas, exhaust gas, etc.
Applicable products		EJ95 ZT16 ZT17 ZT61	*4	EJ95 ZT11 ZT16 ZT17 ZT61	ZT11 ZT16 ZT61

*1 For UC Grade, the pressure transmitter can be manufactured in DOUBLE MELT material by request. Please contact us. functionality to be resumed, when pressure levels return to the normal (rated) range. We can't guarantee full functionality in the case of repeated high pressure above the rated range or static pressure increases lasting 10 minutes or more above the rated range.

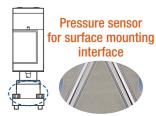
*2 Allowable maximum pressure is the upper limit to which pressure may be temporarily increased while still allowing normal measurement *3 Please confirm that the gas contact part material is suitable for the gas to be measured.

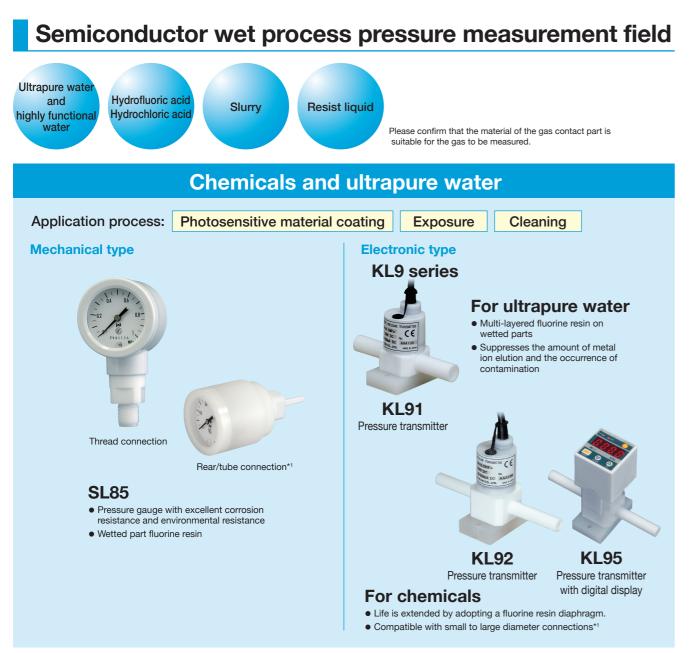
*4 Please contact us for BA grade products.

• UC/EP grade ships with double packing (filled with N2).







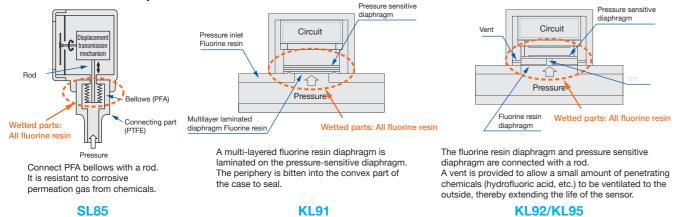


*1 Please contact us for connections not listed in the catalog.

Wetted part structure suitable for chemicals and ultrapure water measurement.

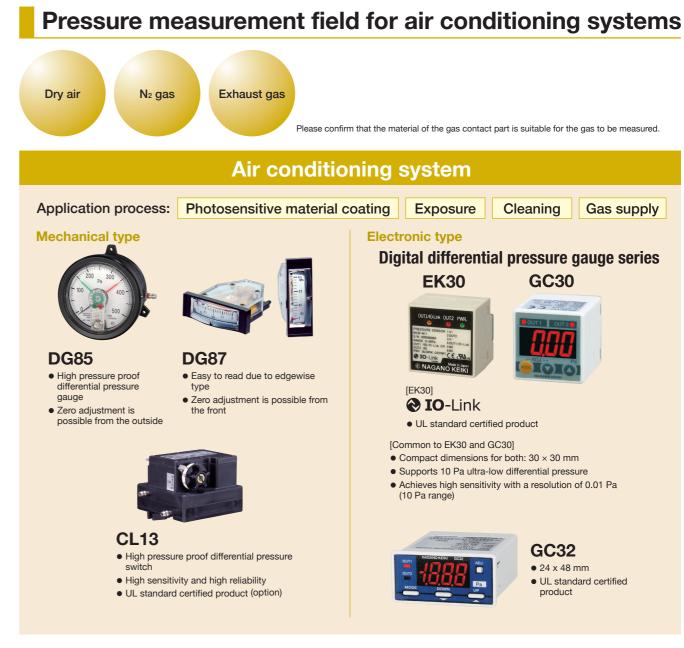
Features of wetted parts

for high corrosion resistance



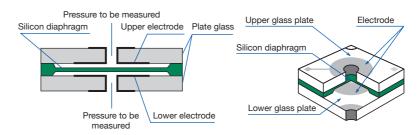
for ultrapure water measurement

for chemicals measurement



Silicon capacitance sensor that can measure with high sensitivity starting at the ultra-fine differential pressure range (10 Pa) and which has a high withstand voltage of 50 kPa at all ranges.

Sensor design

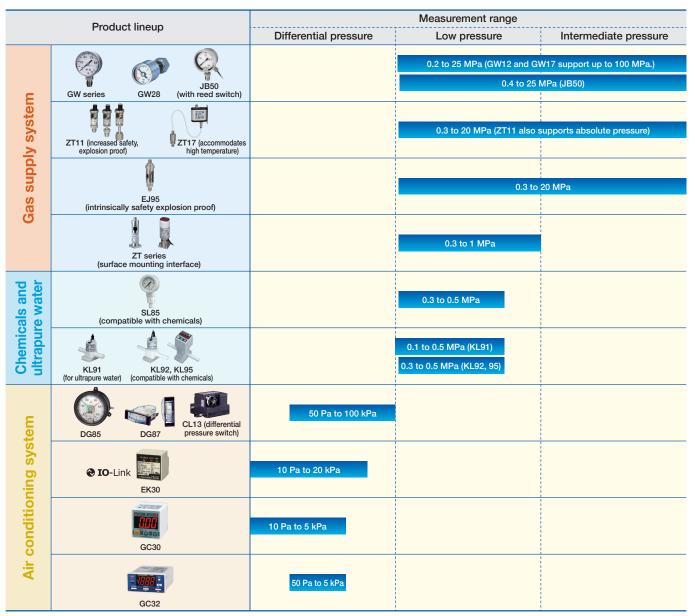


The diaphragm is protected by glass on both sides. When excessive pressure is applied, the glass acts as a stopper, resulting in high pressure resistance





Pressure measurement instruments for the semiconductor industry



• Various compound ranges are also available.

IoT related products



The contents in the catalog are subject to change without notice.

NAGANO KEIKI

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